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on July 15, 2002 (Date of Deposit)
07-15-02 Shelley Hunt
Date Name



3742
#5
PATENT

Attorney Docket No. 4097 P01
m&w Ref. No. APM/063-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
DANIEL HOFFMAN, ET AL.) Group Art Unit: 3742
)
Entitled: MERIE PLASMA REACTOR WITH) Examiner: Unknown
OVERHEAD RF ELECTRODE TUNED TO THE)
PLASMA WITH ARCING SUPPRESSION)
)
Serial No.: 10/007,367)
)
Filing Date: October 22, 2001)

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(b)

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Attached hereto is Form PTO-1449 listing documents believed relevant to the subject application. It is respectfully requested that these documents be made of record and an initialed copy of each form be returned to the undersigned.

No representation is made that more pertinent material is not available or should not be considered by the Examiner. It is expected that the Patent and Trademark Office will independently conduct a complete search of appropriate art. Furthermore, no admission is being made that these documents are prior art, and applicant reserves the right to challenge any such consideration.

It is believed that this disclosure complies with the requirements of 37 CFR 1.56, 1.97, and 1.98, and the Manual of Patent Examining Procedures, section 609 and 707.05. If for some reason the Examiner considers otherwise, it is respectfully requested that the undersigned be called so that any deficiencies can be remedied.

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A copy of each document is enclosed unless indicated otherwise. Some of the documents may have markings on them. No significance is meant to be attached to the markings. These documents are not necessarily analogous art.

Respectfully submitted,

Robert M. Wallace

Dated: July 15, 2002

Robert M. Wallace
Registration No. 29,119
Attorney for Applicants

Robert M. Wallace, Patent Counsel
2112 Eastman Avenue, Suite 102
Ventura, CA 93003
(805) 644-4035

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INFORMATION
DISCLOSURE
CITATION FORM FOR
PATENT APPLICATION
(FORM PTO - 1449)

Docket No.: 4097 P01

Serial No.: 10/007,367

Applicant(s): DANIEL HOFFMAN, ET AL.

Filing Date: 10-22-01

Group: 3742

U. S. PATENTS

Initials	Patent No	Issue Date	Name	Class	Subclass	Filing Date
	5,006,760	04-09-91	DRAKE JR.	315	111.21	01-09-87
	5,055,853	10-08-91	GARNIER	343	769	10-03-88
	5,089,083	02-18-92	KOJIMA ET AL.	156	643	04-20-90
	5,140,223	08-18-92	GESCHE ET AL.	315	111.21	09-25-89
	5,213,658	05-25-93	ISHIDA	156	643	01-23-91
	5,246,532	09-21-93	ISHIDA	156	345	12-10-92
	5,463,525	10-31-95	BARNES ET AL.	361	234	12-20-93
	5,662,770	09-02-97	DONOHUE	438	716	04-16-93
	5,685,914	11-11-97	HILLS ET AL.	118	723	04-05-94
	5,792,376	08-11-98	KANAI ET AL.	216	71	12-29-95
	5,904,799	05-18-99	DONOHUE	156	345	09-06-95
	5,997,962	12-07-99	OGASAWARA ET AL.	427	535	06-28-96
	6,113,731	09-05-00	SHAN ET AL.	156	345	01-02-97
	6,142,096	11-07-00	SAKAI ET AL.	118	723	05-15-97
	6,188,564	02-13-01	HAO	361	234	03-31-99
	6,251,216	06-26-01	OKAMURA ET AL.	156	345	12-16-98
	6,262,538	07-17-01	KELLER	315	111.21	08-26-99
	6,290,806	09-18-01	DONOHUE	156	345	03-24-97
	6,337,292	01-08-02	KIM ET AL.	438	787	10-29-99
	6,346,915	02-12-02	OKUMURA ET AL.	343	701	08-03-00
	re37,580	03-12-02	BARNES ET AL.	361	234	03-18-99

Examiner's Signature:

Date Considered:

Initial if reference was considered, whether or not citation with MPEP. Mark through citation if not considered. Include a copy of this citation form with your next correspondence to the Applicant(s).